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Application Number	10776553
Filing Date	2004-02-10
First Named Inventor	Weimin Li
Art Unit	1755
Examiner Name	Koslow, Carol M.
Attorney Docket Number	MI22-2497

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CMK	1	PAVELCHEK et al., A Highly Absorbing ARC for DUV Lithography, 1996, Proceedings of SPIE, Volume 2724, Pages 692-699.	<input type="checkbox"/>
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